

1        Please substitute the following abstract for the abstract printed in the application.

2                          ABSTRACT

3        (Substitute)        A method of diagnosing semiconductor device functional  
4        testing failures by combining deterministic and functional testing to create a new test pattern  
5        based on the functional failure by determining the location of and type of error in the failing  
6        circuit. This is accomplished by identifying the failing vector during the functional test,  
7        observing the states of the failed device by unloading the values of the latches from the  
8        LSSD scan chain before the failing vector, generating a LOAD from the unloaded states of  
9        the latches, applying the generated LOAD as the first event of a newly created independent  
10      LSSD deterministic pattern, applying the primary inputs and Clocks that produced the  
11      failure to a correctly operating device, unloading the output of the correctly operating device  
12      to generate a deterministic LSSD pattern; and applying the generated deterministic LSSD  
13      pattern to the failing device to diagnose the failure using existing LSSD deterministic tools.

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